Journal of **Materials Chemistry**

Cite this: J. Mater. Chem., 2012, 22, 8083

PAPER www.rsc.org/materials

Polycondensation of thiourea into carbon nitride semiconductors as visible light photocatalysts†

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Received 5th January 2012, Accepted 27th February 2012

DOI: 10.1039/c2jm00097k

Converting solar energy into hydrogen gas by water splitting is considered as a long-term solution to address global energy and environmental problems. Great effort has been devoted to the search for abundant systems for the purpose of efficient capture, conversion, and storage of solar energy in a costeffective manner. To further advance the recently-developed carbon nitride photocatalysis for solar hydrogen generation, thiourea, a sulfur-containing compound, was used as a cheap and easily-available starting material for the synthesis of graphitic carbon nitride semiconductors. The as-prepared photocatalysts were subjected to several characterizations, and the results showed that the heating temperature and the presence of sulfur motifs offer a facile chemical pathway for the control of the condensation/polymerization of carbon nitride, and thus adjusting their textural and electronic properties. Photocatalytic activity experiments demonstrated that the g-C₃N₄ synthesized from thiourea exhibited a much higher H₂ production rate than that of g-C₃N₄ prepared from dicyanamide or urea, and this activity can be further enhanced by increasing the condensation temperature.

Introduction

Catalytically splitting water by sunlight to produce hydrogen gas has attracted worldwide attention due to increasing energy demands and growing greenhouse gas emissions.1 Since the discovery of H₂ production by water splitting in Pt/TiO₂ photoelectrochemical cells in 1972,² enormous efforts have been made to establish stable, efficient and affordable heterogeneous photocatalytic systems for solar to chemical conversion.3 Various kinds of homogeneous and heterogeneous photocatalytic systems have been explored in the past few decades, based mostly on such solar energy transducers as metal oxides,4 metal (oxy)nitrides,5 metal (oxy)sulfides6 and non-metal doped or plasma based TiO2 photocatalysts.7 However, the search for a non-toxic, low cost, but stable and efficient visible light photocatalyst remains a difficult challenge and is actively pursued nowadays.8

Graphitic carbon nitride (g-C₃N₄) polymers, the most stable allotrope of covalent carbon nitride solids at ambient conditions,9 have been successfully introduced as a new metal-free visible light photocatalyst for water reduction and oxidation, owing to their unique electronic band structure. 10 To advance this sustainable photocatalytic material, many strategies have been adopted to modify its physical and chemical properties,

Research Institute of Photocatalysis, Fujian Provincial Key Laboratory of Photocatalysis-State Key Laboratory Breeding Base, Fuzhou University, Fuzhou 350002, People's Republic of China. E-mail: xcwang@fzu.edu.cn † Electronic supplementary information (ESI) available: characterization of XRD, FT-IR and UV-Vis spectra for CN-U samples; EPR spectra for bulk and mpg-C₃N₄ samples. See DOI: 10.1039/c2jm00097k

such as doping,11 sensitization,12 nanostructured design,13 and hybridization,14 as well as copolymerization.15 In addition, the use of different precursors that contain C≡N core structures for g-C₃N₄ synthesis has also been proven to be an effective means of enhancing the photocatalytic performance of g-C₃N₄. For example, g-C₃N₄ synthesized from dicyanodiamide (DCDA) showed a better photoactivity for methylene blue (MB) degradation than g-C₃N₄ synthesized from cyanamide (CA) and melamine (MA).16 Using sulfur containing C≡N based compounds as the precursors for g-C₃N₄ preparation, such as trithiocyanuric acid (TA)¹⁷ and ammonium thiocyanate (AT),¹⁸ can alter the traditional way of monomer condensation/polymerization by the sulfur-mediated effect, optimizing its textural, optical and electronic properties for photoredox catalysis.

Very recently, urea, an oxygen-containing compound, has been thermally-transformed into polymeric g-C₃N₄. ¹⁹ The resultant photocatalyst showed enhanced photocatalytic reactivity for dye degradation under visible light irradiation, due mainly to the surface enlargement effect. The possible reaction mechanism for urea conversion into a g-C₃N₄ network at high temperatures is presented in Scheme 1, where oxygen compounds act as additional leaving motifs to facilitate the condensation of carbon nitride materials, and thus enable structural perfection.¹⁹ What will happen if oxygen atoms are substituted by sulfur atoms? Do g-C₃N₄ networks still form when thiourea (TU) is used as the starting material, which has a similar molecular structure to urea, but with easy-leaving groups of sulfur species? In principle, TU can undergo self-polymerization and condensation at high temperature to form g-C₃N₄ networks (Scheme 1), whereas the sulfur species can promote the connectivity and packing of g-C₃N₄ sheets, as already known in the TA condensation scheme.¹⁷ It is reported that a melon structure has been obtained at low temperature (400 °C) by using TU as the starting material, with the aid of TiO₂ or SiO₂.²⁰ However, the very low degree of polymerization and the incomplete formation of an electronic band structure impart the carbon nitride polymers with very moderate performances in photocatalytic applications.²⁰ Thus, the synthesis of well-condensed g-C₃N₄ photocatalysts from TU is still necessary, especially without the aid of inorganic substrates to support polymerization/condensation, while also taking advantage of a sulfur-mediated synthesis using easily available TU instead of TA to promote bulk condensation kinetically.

In this paper, TU was used as a single precursor for g- C_3N_4 synthesis at different temperatures. The textural structures, optical and electronic properties of the resultant samples were carefully examined. The TU-derived g- C_3N_4 photocatalysts were applied in solar hydrogen production, and the performance was compared with other g- C_3N_4 solids obtained from conventional starting materials, such as DCDA and urea.

2. Experimental

2.1. Preparation of g-C₃N₄

g- C_3N_4 photocatalysts were prepared by directly heating TU at different temperatures for 2 h in air, and the resultant samples were denoted as CN- T_x , where x refers to the calcination temperature. For comparison, DCDA and urea were also used as the starting materials for carbon nitride synthesis under the same preparation conditions, and the obtained samples were denoted as CN- D_x and CN- U_x , respectively.

2.2. Characterization

Powder X-ray diffraction (XRD) measurements were performed on a Bruker D8 Advance diffractometer with Cu-K α 1 radiation ($\lambda = 1.5406$ Å). Fourier transform infrared (FTIR) spectra were recorded on a BioRad FTS 6000 spectrometer. X-Ray photoelectron spectroscopy (XPS) data were obtained on a Thermo ESCALAB250 instrument with a monochromatized Al K α line source (200 W). Nitrogen adsorption–desorption isotherms were collected at 77 K using a Micromeritics ASAP 2020 surface area

$$\begin{array}{c} O = C = NH \\ H_2N \stackrel{\overset{\frown}{C}}{\overset{\frown}{C}} \cdot NH_2 \stackrel{-NH_3}{\overset{\frown}{\Delta}} + \begin{array}{c} O = C = NH \\ H_2N \stackrel{\overset{\frown}{C}}{\overset{\frown}{C}} \cdot NH_2 & NH_2 \\ H_2N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_2 \\ H_2N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_2 \\ H_2N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_3 \\ H_2N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_2 \\ N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_2 \\ N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_3 \\ N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_3 \\ N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_2 \\ N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_2 & NH_3 \\ N \stackrel{-NH_3}{\overset{\frown}{C}} \cdot NH_3 NH_3 \\ N \stackrel{-NH_3}{\overset{\frown}{C}}$$

Scheme 1 The self-polymerization of urea and thiourea into a graphitic carbon nitride network at high temperatures.

and porosity analyzer. Transmission electron microscopy (TEM) was performed by a Zeiss 912 microscope and a JEOL mode JEM 2010 EX instrument. Electron paramagnetic resonance (EPR) measurements were carried out on a Bruker model A300 spectrometer. UV-Vis diffuse reflectance spectra (DRS) were performed on a Varian Cary 500 Scan UV-visible system. Photoluminescence spectra were recorded on a Edinburgh FI/FSTCSPC 920 spectrophotometer. Elemental analysis (EA) results were collected from a Vario MICRO. TGA was performed on a TG209 (NETZSCH Co.). Electrochemical measurements were conducted with a BAS Epsilon Electrochemical System in a conventional three electrode cell, using a Pt plate as the counter electrode and an Ag/AgCl electrode (3 M KCl) as the reference electrode.

2.3. Photocatalytic activity for hydrogen evolution

Reactions were carried out in a Pyrex top-irradiation reaction vessel connected to a glass closed gas system. H₂ production was performed by dispersing 50 mg of catalyst powder in an aqueous solution (100 mL) containing triethanolamine (10 vol%) as a sacrificial electron donor. 3 wt% Pt was loaded on the surface of the carbon nitride catalyst by the *in situ* photodeposition method using H₂PtCl₆. The reaction solution was evacuated several times to remove air completely prior to irradiation under a 300 W xenon-lamp and a water filter. The wavelength of the incident light was controlled by applying appropriate long-pass cut-off filters. The temperature of the reaction solution was maintained at room temperature by the flow of cooling water during the reaction. The evolved gases were analyzed by gas chromatography equipped with a thermal conductive detector (TCD) and a 5 Å molecular sieve column, using argon as the carrier gas.

Details for Pt *in situ* loading: $100~\mu L$ of H_2PtCl_6 aqueous solution (Sigma-Aldrich, $0.015~g\,mL^{-1}$ based on Pt) was added to the reaction solution (100~mL) containing $50~mg~g-C_3N_4$ and 10~vol% triethanolamine. The reaction system was then closed and the solution was evacuated 10~times to remove the air completely. A Xe-lamp equipped with IR and 420 nm filters was turned on to induce the *in situ* photodeposition of Pt particles on the carbon nitride polymers.

3. Results and discussion

3.1. Formation of g-C₃N₄

To demonstrate the formation of well condensed graphitic-like conjugated aromatic systems and the complete development of semiconductor band structures, the as-prepared CN-T $_{550}$, together with CN-D $_{550}$ and CN-U $_{550}$ as the references, was subjected to several characterizations, such as XRD, FT-IR, XPS, N $_2$ -sorption, TEM and EPR. In addition, the differences in the textural structure, optical and electronic properties between CN-T $_{550}$ and the reference samples were also discussed.

In Fig. 1a, highly graphitic-like structures are observed for CN-T₅₅₀ and the reference samples, suggesting the formation of a well-developed C_3N_4 layer structure. The strongest XRD peak, originating from the (002) interlayer reflection of a graphitic-like structure, is determined as 27.4°, corresponding to an interlayer distance of d = 0.326 nm. This interlayer distance is almost the same as that of CN-D₅₅₀, but is slightly smaller than

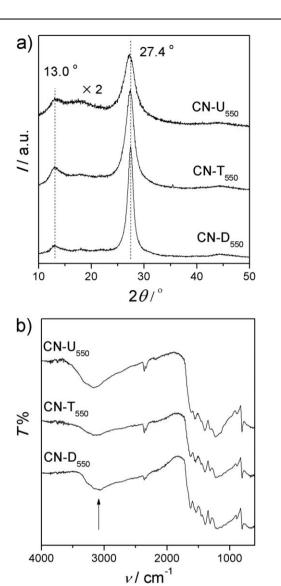


Fig. 1 XRD patterns (a) and FT-IR (b) spectra of CN-U₅₅₀, CN-T₅₅₀ and CN-D₅₅₀.

that of CN-U₅₅₀ (d = 0.328 nm).¹⁸ In the case of the other pronounced XRD peak at ca. 13.0°, related to in-plane repeated units, no obvious difference can be detected among the samples of CN-T₅₅₀, CN-D₅₅₀ and CN-U₅₅₀. This indicates that the three samples possess virtually the same void-to-void distance (d =0.681 nm) of the in-plane structural repeating motifs.^{9,18} In addition, the intensity of the XRD patterns is found to be different from each other depending on the starting materials. The XRD peak of CN-T₅₅₀ is found to be less strong than that of CN-D₅₅₀, but it is stronger and sharper than that of CN-U₅₅₀. We attribute the weak and broad XRD peaks of CN-U₅₅₀ to the disturbance of the graphitic-like structure, which is related to its enlarged surface area and the presence of nanostructures (Fig. 3).15,18

Fig. 1b shows the FT-IR spectra of the three samples. All of the characteristic vibration modes assigned to typical g-C₃N₄ are clearly seen for CN-T₅₅₀, indicating the successful evolution of the g-C₃N₄ structure. The strong bands at 1200–1600 cm⁻¹ are assigned to the stretching vibration of the heptazine heterocyclic

ring (C_6N_7) units, while the sharp peak at 805 cm⁻¹ is considered as their breathing mode.¹⁵ The broad peak located at 2900-3300 cm⁻¹ is attributed to the residual N-H components and the O-H bands, associated with the uncondensed amino groups and the absorbed H₂O molecules, respectively. The CN-T₅₅₀ sample is observed to present a lower intensity of the broad band at $2900-3300~\text{cm}^{-1}$ than both the CN-D₅₅₀ and CN-U₅₅₀ samples, indicating the accelerated and improved condensation of g-C₃N₄ through the sulfur-mediated synthesis. 17,18 The weak absorption at 2350 cm⁻¹ is due to absorbed CO₂ molecules on the g-C₃N₄ surface.21

The chemical structure and composition of CN-T₅₅₀ were further revealed by XPS measurements. In the XPS survey spectrum, as shown in Fig. 2a, there are only three elements (C, N, and O) observed. No signal assigned to the sulfur species can be found, which is similar to the results for AT-derived g-C₃N₄. This gives evidence that the function of the sulfur species in these CN precursors is to mediate the g-C₃N₄ condensation/polymerization instead of to dope/modify the carbon nitride semiconductors.17,18 The O 1s signal is presumably due to the absorbed H₂O or CO₂ molecules on the CN-T₅₅₀ surface, as also confirmed by the above FT-IR analysis (Fig. 1b).18 High-resolution spectra of C 1s, N 1s and S 2p are also shown in Fig. 2. There are mainly two carbon species present in the C 1s spectrum, and the corresponding binding energies are determined to be 284.6 eV and 288.1 eV. The former peak, according to the literature, is typically ascribed to sp² C-C bonds, whereas the latter is identified as sp²-bonded carbon in N-containing aromatic rings (N-C=N), which is regarded as the major carbon species in the g-C₃N₄ polymer.⁹ The N 1s spectrum can be deconvoluted into four peaks at 398.7 eV, 400.3 eV, 401.4 eV and 404.2 eV. The main peak centered at 398.7 eV originates from the

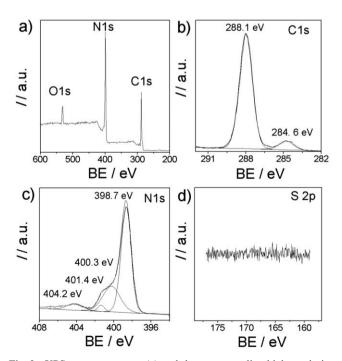


Fig. 2 XPS survey spectrum (a) and the corresponding high-resolution spectra of C1s (b), N1s (c), S2p (d) that are obtained from the CN-T₅₅₀ sample.

It is noted that the textural structure of the final g-C₃N₄ polymers is strongly dependant on the different C \equiv N based precursors used. For example, the urea-derived g-C₃N₄ possesses a large surface area (\sim 58 m² g⁻¹ for CN-U₅₅₀). However, in the case of thiourea, the specific surface area (S_{BET}) of CN-T₅₅₀ is determined as 18 m² g⁻¹, according to the nitrogen adsorption–desorption experiments, as shown in Fig. 3. This indicates that the heteroatoms, oxygen and sulfur, play a very important role in the processing of carbon nitride condensation, and oxygen is found to be more efficient for enlarging the surface area of g-C₃N₄, presumably due to the formation of CO₂ during the polymerization to inhibit grain advance by chemisorption at basic docking sites. The S_{BET} of CN-D₅₅₀ was measured as 10 m² g⁻¹.

Fig. 4 shows the typical TEM images of CN-D $_{550}$, CN-T $_{550}$ and CN-U $_{550}$, respectively. Similar to the results of the nitrogen adsorption—desorption experiments, the starting materials also have a significant influence on the morphological evolution of the terminal g-C $_3$ N $_4$ samples. CN-D $_{550}$ is mainly composed of large particles and sheets, whereas much smaller sizes of particles and sheets are clearly observed for the CN-T $_{550}$ sample. The morphology of CN-U $_{550}$ was quite different, and many smooth, thin and flat layers were clearly seen in Fig. 4c. This typical silk-like morphology imparts CN-U $_{550}$ with a large specific surface area, as demonstrated previously.

Room-temperature EPR analysis was carried out to investigate the electronic band structure of the g- C_3N_4 polymers. In Fig. 5, only one single Lorentzian line centered at a g value of 2.0034 is observed for all of the g- C_3N_4 samples, indicating the

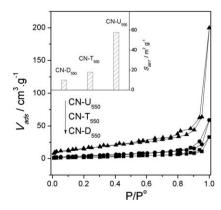


Fig. 3 N_2 adsorption–desorption isotherms and the corresponding specific surface area (inset) of CN-D₅₅₀, CN-T₅₅₀ and CN-U₅₅₀.

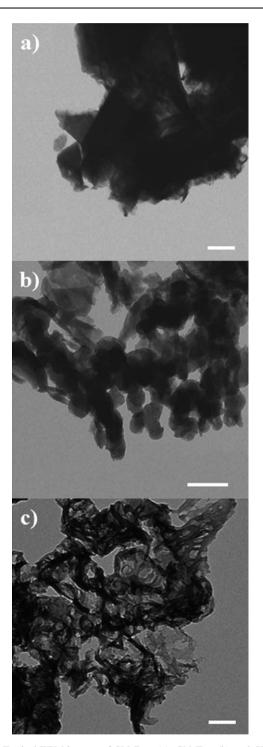


Fig. 4 Typical TEM images of CN-D₅₅₀ (a), CN-T₅₅₀ (b) and CN-U₅₅₀ (c), respectively. The scale bars are 200 nm.

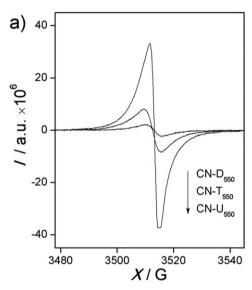
establishment of a semiconductor structure at 550 °C in the three samples. These Lorentzian lines, according to the literature, originate from the unpaired electrons in the aromatic rings of carbon atoms, within the π -bonded nanosized clusters on the surface of the materials. ^{15b,22} In addition, the intensity of the Lorentzian lines is quite different, obeying a linear correlation with the corresponding surface area of the samples (Fig. 5b). A similar conclusion can also be derived for mpg-C₃N₄ and bulk

g-C₃N₄ synthesized from cyanamide (Fig. S2†). mpg-C₃N₄ with a large surface area (128 m² g⁻¹) exhibits a stronger Lorentzian line than bulk g-C₃N₄ ($S_{BET} = 11 \text{ m}^2 \text{ g}^{-1}$), consistent with the density of surface sites.

3.2. Influence of heat treatment

In the following set of experiments, we focus on the influence of heating temperature on the textural structure, optical and electronic properties of $CN-T_x$.

Fig. 6a shows the XRD patterns of the TU-derived carbon nitride samples condensed at different heating temperatures. It can be seen that at 450 °C, graphitic-like networks are formed but are incomplete, because the reaction temperature is too low to provide enough energy for thiourea condensation. Upon increasing the temperature to 500 °C, typical graphitic-like layered structures form, with the appearance of a (002) and (100) peak in the XRD patterns. Further increasing the temperature to 550 and 600 °C can optimize the polycondensation of g-C₃N₄, but excessive thermal energy at 650 °C can induce the



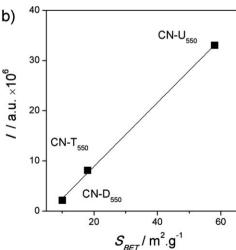
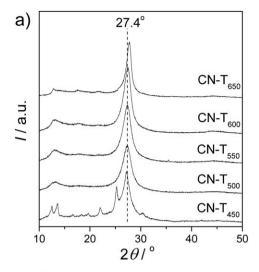


Fig. 5 EPR signals (a) and the correlation between S_{BET} and the peak intensity (b) of CN-D₅₅₀, CN-T₅₅₀ and CN-U₅₅₀ at room temperature.



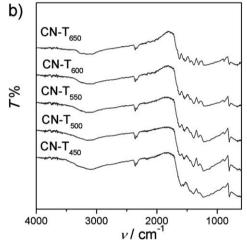


Fig. 6 XRD patterns (a) and FT-IR spectra (b) of the $CN-T_x$ samples.

decomposition of the carbon nitride polymer (Fig. 7c). 18,19 For example, when the reaction temperature reaches 650 °C, the (002) peak up-shifts to $2\theta = 27.9^{\circ}$, resulting in a more compact g- C_3N_4 with an interlayer distance of d = 0.320 nm. Further increasing the temperature to 700 °C causes the completely combustion of g-C₃N₄ in air.

A similar structural evolution trend can be inferred from the FT-IR spectra (Fig. 6b) of the samples prepared at different temperatures. At low temperatures, such as 450 °C, the incomplete condensation of thiourea results in the weak vibration of the C₆N₇ units at 1200 to 1600 cm⁻¹ and 805 cm⁻¹, with a quite strong signal for residual N-H components from 2900 cm⁻¹ to 3300 cm⁻¹. This poor condensation can be improved by increasing the heating temperature to promote the process of g-C₃N₄ formation. However, the rate of sample self-decomposition accelerates at the same time, when the sample was subjected to sintering at >650 °C.

Fig. 7 shows the N₂-sorption analysis and the corresponding surface area of g-C₃N₄ synthesized at different temperatures, together with the thermal analysis of the g-C₃N₄ in air. When the heating temperature exceeds 550 °C, above the onset decomposition temperature of the g-C₃N₄ polymers, the weight loss happens quickly, accompanied by the significant

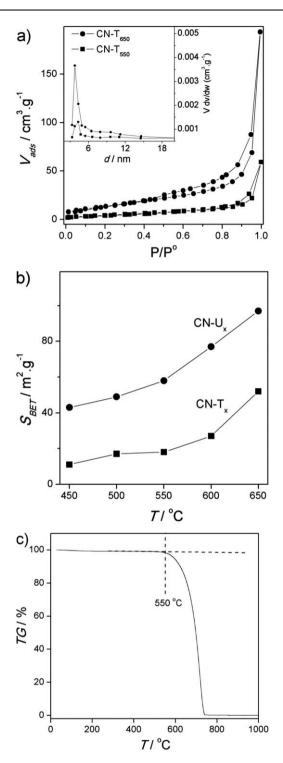


Fig. 7 (a) N_2 adsorption–desorption isotherms and the corresponding BJH pore-size distribution (inset) of CN-T₅₅₀ and CN-T₆₅₀. (b) The correlation between $S_{\rm BET}$ and the heating temperature for CN-T_x and CN-U_x. (c) Thermogravimetric analysis (TGA) results for CN-T₆₀₀.

enlargement of $S_{\rm BET}$ and the generation of nanopores (Fig. 7 and Table 1). For example, increasing the condensation temperature from 550 °C to 650 °C causes a great enhancement of the specific surface area from 18 m² g⁻¹ for CN-T₅₅₀ to 52 m² g⁻¹ for CN-T₆₅₀.

TEM images provide us with clear evidence of the thermal decomposition behavior (Fig. 4b and Fig. 8). In comparison to CN-T₅₅₀, g-C₃N₄ sheets with much smaller particle sizes are visible in the 650 °C condensed sample (CN-T₆₅₀), owing to the serious decomposition of g-C₃N₄ in the presence of oxygen. This thermal behavior of the carbon nitride photocatalysts is contrary to most porous inorganic photocatalysts, which typically undergo structure deformation/collapse with decreased surface area upon enhancing the sintering temperature to improve crystal growth. However, it is observed that for carbon nitride organosemiconductors, the nanostructure can be self-introduced by a simple thermal treatment. This is a remarkable observation, as the creation of porous structures in the polymeric carbon nitride frameworks typically relies on complicated hard-templating methods using nanosized SiO₂ particles and mesoporous SBA-type zeolites to support the polymerization of the carbon nitride precursors, followed by the careful removal of the templates with HF or NH₄HF₂. 9,13 The slight thermal decomposition will also create surface sites to facilitate catalytic sorption and also to promote the localization of light-induced electrons in the conjugated systems, which has already been demonstrated be beneficial for carbon to nitride photocatalysis. 13a,b

The relationship between the optical properties and the heating temperatures is examined by UV-vis and photoluminescence (PL) spectra. In Fig. 9, a typical semiconductor absorption in the blue light range is observed for all CN-T_x samples, which originates from electronic transitions from the VB to the CB.10 Their absorption edges are varied by changing the calcination temperature. Firstly, with increasing the temperature from 450 °C to 550 °C, an obviously reduced band gap energy from 2.71 eV to 2.58 eV is detected (Table 1), owing to the extension of electron delocalization in the aromatic sheets with enhanced structural connections, somewhat similar to the bathochromic shift effect in J-aggregates. 13,18 Further increasing the condensation temperature causes the slight blue-shift of the absorption edges, for instance, a bigger band gap of 2.76 eV is determined for CN-T₆₅₀. This hypsochromic-shift performance is presumably due to the strong quantum confinement effects, because high temperatures can induce the thermal decomposition of g-C₃N₄ into smaller particles (Fig. 7 and 8). However, the H-aggregates inducing a hypsochromic-shift in the optical spectrum following the improved condensation at 650 °C cannot be exclusively ruled out, because the layer structure is indeed found to be compressed to a smaller inter-plane distance from d = 0.326 nm (550 °C) to $d = 0.320 \text{ nm } (650 \,^{\circ}\text{C}).$

Fig. 10 gives the PL spectra of different samples, showing that the PL intensity increases with increasing temperature from 450 °C to 500 °C, due to the gradual formation of a semiconductor band structure. The PL spectra become broader and less intense with further increased heating temperature, because the presence of thermally-induced nanostructures (Fig. 7) can cause the electron relocalization on surface terminal sites, which is believed to promote photocatalytic redox functions. ^{13a,b}

The charge generation and separation within g-C₃N₄/water interfaces (similar to semiconductor/electrolyte interfaces, SEI) is the basic process for photocatalytic water splitting. The photoelectrochemistry setup provides a simple but powerful tool to monitor this process.¹⁵ Powder catalysts are made as film

Table 1 Physicochemical properties and photocatalytic activity of g-C₃N₄ polymers for H₂ evolution with visible light

Catalyst	C/N atomic	$S_{ m BET}{}^a/{ m m}^2~{ m g}^{-1}$	Band gap ^b /eV	$\mathrm{HER}^{c}/\mu\mathrm{mol}\ \mathrm{h}^{-1}$
CN-D ₅₅₀	0.73	10	2.75	12.1
CN-T ₄₅₀	0.66	11	2.71	5.7
CN-T ₅₀₀	0.68	17	2.70	30.3
CN-T ₅₅₀	0.70	18	2.58	90.7
CN-T ₆₀₀	0.72	27	2.62	151.1
CN-T ₆₅₀	0.76	52	2.76	157.2
CN-U ₄₅₀	0.78	43	2.79	3.4
CN-U ₅₀₀	0.76	49	2.70	23.5
CN-U ₅₅₀	0.76	58	2.66	79.0
CN-U ₆₀₀	0.75	77	2.67	109.1
CN-U ₆₅₀	0.73	97	2.69	89.8

^a Calculated from nitrogen adsorption-desorption isotherms. ^b Estimated from optical measurements. ^c H₂ evolution rate.

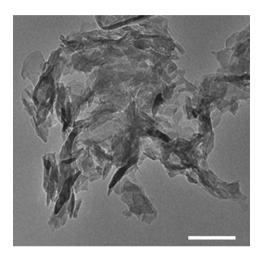


Fig. 8 Typical TEM image of CN-T₆₅₀. The scale bar is 200 nm.

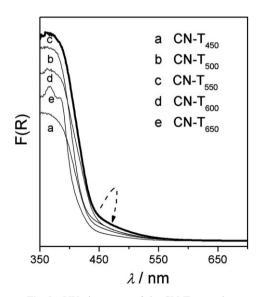


Fig. 9 UV-vis spectra of the CN- T_x samples.

electrodes on fluorine doped tin oxide (FTO) glass by a dropcoating method. Then, these film electrodes are immersed into a 0.2 M Na₂SO₄ electrolyte, under visible light ($\lambda > 420$ nm) illumination to generate photocurrents. As shown in Fig. 11,

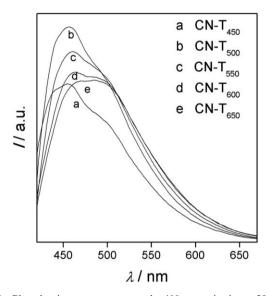


Fig. 10 Photoluminescence spectra under 400 nm excitation at 298 K for the CN-T_x samples.

obvious anodic photocurrents are generated by the g-C₃N₄ photoelectrodes at 0.4 V vs. Ag/AgCl, indicating the efficient generation and separation of photoinduced electron-hole pairs within the SEI. CN-T₆₅₀ produces a bigger photocurrent than CN-T₅₅₀, owing to its better condensation and enlarged surface area, which is favorable for charge collection and separation at the interfaces.

Photocatalytic activity

The photocatalytic activity of the resulting g-C₃N₄ samples was evaluated by H₂ production from aqueous proton solution under visible light irradiation ($\lambda > 420$ nm). Chloroplatinic acid and triethanolamine were used as precursors to create H₂ reduction sites (Pt nanoparticles) and electron donors, respectively. CN- T_{550} (with a catalytic performance of 90.7 µmol h^{-1}) shows the best H₂ evolution activity over the samples of CN-U₅₅₀ $(79.0 \, \mu \text{mol h}^{-1})$ and CN-D₅₅₀ (12.1 $\mu \text{mol h}^{-1}$), albeit a larger S_{BET} was detected for CN-U₅₅₀ and a better crystallinity was observed for CN-D₅₅₀ (Table 1). The H₂ evolution activities of the other $CN-T_x$ and $CN-U_x$ samples are also summarized in Table 1. Not

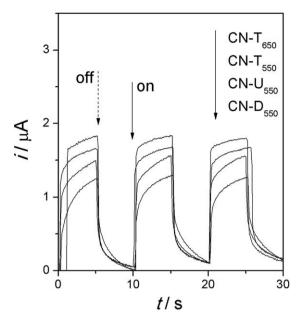


Fig. 11 Transient photocurrent generation from g-C₃N₄/FTO electrodes at 0.4 V vs. Ag/AgCl in 0.2 M Na₂SO₄ under visible light irradiation ($\lambda > 420$ nm). The active surface area of the film electrode was controlled as 0.25 cm².

unexpectedly, their activities varied greatly with heating temperature, again reflecting the importance of heat treatment for photocatalyst synthesis.

Fig. 12a shows the time course of H_2 evolution obtained over the CN- T_{650} sample under visible light (λ > 420 nm) irradiation. The production of H_2 increases steadily with prolonged time of light irradiation. After four consecutive runs (12 h), a total of 1.1 mmol H_2 gas (24.6 mL) is produced, and no obvious deactivation of the photocatalysts is found, suggesting the good stability of CN- T_{650} as an organic photocatalyst for solar H_2 generation. This is very important, because good stability is regarded as a crucial basis for a photocatalyst for solar energy application.

To further confirm that water reduction is indeed driven by visible absorption by the carbon nitride catalyst, a wavelength-dependent $\rm H_2$ evolution experiment was also performed. In Fig. 12, the trend of $\rm H_2$ production matches well with the UV-vis spectrum of CN-T₆₅₀, and the longest wavelength available for $\rm H_2$ evolution is about 550 nm. This observation strongly supports that the water reduction process is primarily induced by light-excitation of electrons in the carbon nitride polymer.

4. Conclusions

In summary, g-C₃N₄ photocatalysts have been successfully synthesized from thiourea at different temperatures in air. The presence of the sulfur species offers an extra chemical control for the synthesis of graphitic carbon nitride networks, accelerating the processing of the g-C₃N₄ polymerization/condensation. In addition, the condensation temperature was found to affect the formation of g-C₃N₄ greatly. Increasing the heating temperature to 650 °C not only favors the g-C₃N₄ formation, but also accelerates the partial decomposition of the catalyst itself, *in situ*,

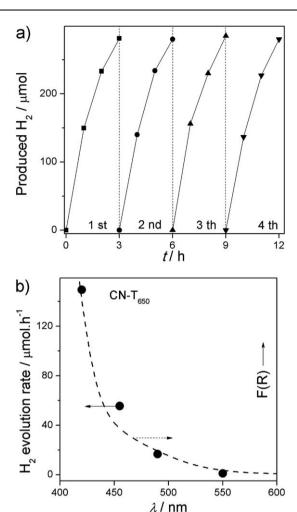


Fig. 12 (a) Time course of H_2 evolution for CN-T₆₅₀ under visible light irradiation ($\lambda > 420$ nm). (b) Wavelength dependence of H_2 evolution rate on CN-T₆₅₀, the dashed line is the UV-vis spectra of CN-T₆₅₀.

creating nanostructures in the bulk carbon nitrides. Therefore, one can easily optimize the textural, electronic and optical properties of carbon nitride semiconductors by the combination of a sulfur-mediated synthesis and the thermally-induced generation of nanostructures. These optimized g-C₃N₄ photocatalysts can, in principle, be implemented in other applications of catalysis and photocatalysis, such as selective organic photosynthesis and environmental protection.²³

Acknowledgements

This work is financially supported by the National Natural Science Foundation of China (21033003 and 21173043). The authors thank Dr M. J. Bojdys for the helpful discussions.

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